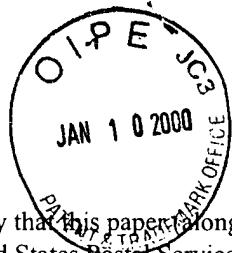


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Attorney Docket No. 3245

1-12-00



CERTIFICATE OF MAILING

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first-class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, DC 20231.

Date: 1/4/00

Charles S. Guenzer

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Hoiman (Raymond) Hung et al.

Docket: AM-3245

Serial No. 09/276,376

Group No. 1746

Filed: March 25, 1999

Examiner: unknown OLSen

For: ENHANCEMENT OF SILICON OXIDE ETCH RATE AND SUBSTRATE  
SELECTIVITY WITH XENON ADDITION

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN  
THREE MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

The information disclosure statement submitted herewith is being filed within three months of the filing of the application or before issuance of the first Office action on merits, whichever comes last, in accordance with 37 CFR 1.97(b). Transmitted herewith are the following:

1. Form PTO-1449 (1 page)
2. References (6)

It is believed that no fee is required. However, at any time during the pendency of this application, please charge any fees required or credit any overpayments to Deposit Account No. 50-0636.

Respectfully submitted,

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